



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 6, 2026	
IGI Report Number	LG788652039
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OLD EUROPEAN CUT
Measurements	9.90 - 9.94 X 6.44 MM

GRADING RESULTS

Carat Weight	4.08 CARATS
Color Grade	D
Clarity Grade	VVS 2

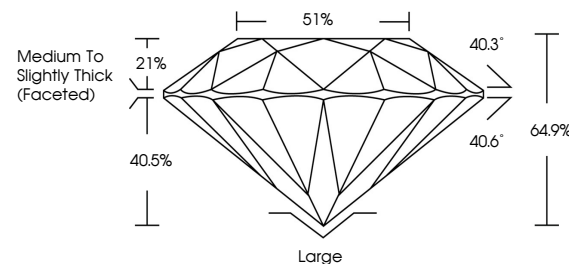
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG788652039

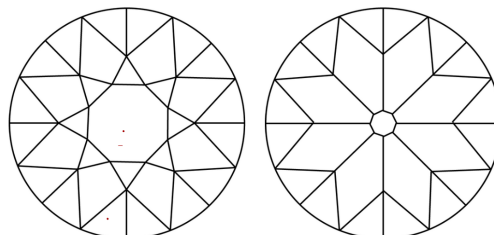
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG788652039
Report verification at lgi.org

PROPORTIONS

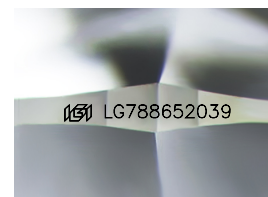


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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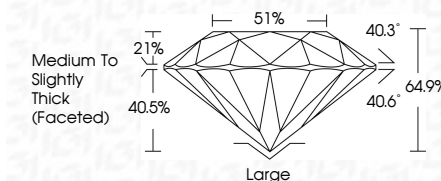
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Type IIa



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www.igi.org

April 6, 2006	CD Record No. LG789652039	438 CARATS	D
CD EUROPEAN CUT	9.0 - 9.6 X 6.4 MM	VVS 2	64%
		61%	51%
		Medium to Slightly Thick (Faceted)	
		Large	
		EXCELLENT	
		EXCELLENT	
		NONE	
		681 LG789652039	

Comments: Very Good Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA